



#910  
4-15-03  
PATENT

Customer No. 22,852  
Attorney Docket No. 04788.0247-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )

Yasuhiro OMURA )

Application No.: 09/865,734 )

Filed: May 29, 2001 )

For: PROJECTION OPTICAL SYSTEM, )  
EXPOSURE APPARATUS )  
INCORPORATING THIS PROJECTION )  
SYSTEM, AND MANUFACTURING )  
METHOD FOR MICRO DEVICES USING )  
THE EXPOSURE APPARATUS )

Group Art Unit: 2851

Examiner: Hung Nguyen

RECEIVED  
APR 10 2003  
TECHNOLOGY CENTER 2800

Commissioner for Patents  
Washington, DC 20231

Sir:

**AMENDMENT**

In reply to the Office Action dated December 4, 2002, the period for reply having been extended for one month to April 4, 2003, by a Request for Extension of Time and fee payment filed concurrently herewith, please amend the application as follows:

**ABSTRACT**

Please replace the abstract with the abstract suggested on the attached separate sheet.

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